

DOCKET NO: 206342US2



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
TOSHIFUMI NAGAIWA, ET AL. : EXAMINER: R. KACKAR
SERIAL NO: 09/840,178 :
2ND RCE FILED: HEREWITH : GROUP ART UNIT: 1763
FOR: WORKTABLE DEVICE AND :
PLASMA PROCESSING APPARATUS
FOR SEMICONDUCTOR PROCESS

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Please amend the above-identified application as indicated in the following.

Amendments to the Claims are reflected in the listing of claims which begins on
page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.